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PATENT  
0020-4931P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Masayuki OHTA Conf.: 8299  
Appl. No.: 09/994,673 Group: 1762  
Filed: November 28, 2001 Examiner: T. H. MEEKS  
For: METHOD FOR EVENLY COATING SEMICONDUCTOR  
LASER END FACES AND FRAME USED IN THE  
METHOD

LARGE ENTITY TRANSMITTAL FORM

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 10, 2003

Sir:

Transmitted herewith is a Reply to Restriction/Election Requirement in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ Petition for \_\_\_\_\_ ( ) month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- ☒ No fee is required.
- ☐ A check in the amount of \$0.00 is enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. A triplicate copy of this sheet is attached.

Appl. No. 09/994,673

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 

Terrell C. Birch, #19,382

RW  
TCB/RWD/lab  
0020-4931P

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Attachment(s)

(Rev. 04/30/03)